

RESPONSE UNDER 37 CFR 1.116 EXPEDITED PROCEDURE EXAMINING GROUP 2881

03560.002732

## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	:	Examiner: K. Fernandez
Masato MURAKI et al.	)	
	:	Group Art Unit: 2881
Application No.: 09/708,590	)	
	:	Confirmation No.: 2106
Filed: November 9, 2000	)	
	:	
For: CORRECTING METHOD FOR	)	
CORRECTING EXPOSURE DATA USED	:	
FOR A CHARGED PARTICLE BEAM	)	
EXPOSURE SYSTEM	:	August 16, 2004

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **AMENDMENT AFTER FINAL ACTION**

Sir:

In response to the Official Action dated May 19, 2004, please amend the above-identified application as follows pursuant to 37 CFR 1.116:

OK Enbi Enbi